

DOCKET NO: 284901US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

HACHISHIRO IIZUKA : EXAMINER: KEATH T. CHEN

SERIAL NO: 10/565,676 :

FILED: JANUARY 24, 2006 : GROUP ART UNIT: 1792

FOR: GAS REACTION SYSTEM AND :
SEMICONDUCTOR PROCESSING
APPARATUS

"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 1792"

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
Alexandria, VA 22313

Sir:

In response to the Office Action of November 9, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.